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#17/Expt 10
F
PATENT
9/15/03

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant : Stephen L. Willis
Appl. No. : 09/552,383
Filed : April 19, 2000
For : CHEMICAL MECHANICAL
PLANARIZATION OF
CONDUCTIVE MATERIAL
Examiner : Jose R. Diaz
Group Art Unit : 2815

CERTIFICATE OF MAILING

I hereby certify that this correspondence and all marked attachments are being deposited with the United States Postal Service as first-class mail in an envelope addressed to: Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450, on

September 5, 2003

(Date)

Michael H. Tenholm, Reg. No. 37,743

RESPONSE TO OFFICE ACTION

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Dear Sir:

In response to the Office Action mailed May 5, 2003 (Paper No. 15) and to the personal interview between the Examiner and the Applicant's undersigned representative held July 11, 2003, the Applicant amends the above-identified application as follows and respectfully requests reconsideration of the rejected Claims 30-37 and 56-62 based on the interview and on the following amendment.

Amendments to the Claims are reflected in the listing of claims which begins on page 2 of this paper.

Remarks/Arguments begin on page 6 of this paper.

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